

Notice of References Cited	Application/Control No. 10/562,121		Applicant(s)/Patent Under Reexamination BAUBET ET AL.	
	Examiner LAUREN ROBINSON		Art Unit 1794	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,316,110 B1	11-2001	Anzaki et al.	428/432
*	B	US-2002/0086164 A1	07-2002	Anzaki et al.	428/432
*	C	US-2002/0139772 A1	10-2002	Fenner, David B.	216/60
	D	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Handbook of Sputter Deposition Technology"
	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.